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PATENT  
3731-0144P

IN THE U.S. PATENT AND TRADEMARK OFFICE

Applicant: Victor KATSAP, et al.  
Appl. No.: 09/414,004 Group: 2881  
Filed: October 7, 1999 Examiner: K. Fernandez  
For: LENS ARRAY FOR ELECTRON BEAM  
LITHOGRAPHY TOOL (As Amended)

PROPOSED DRAWING CORRECTION APPROVAL REQUEST

Assistant Commissioner for Patents  
Washington, DC 20231

April 9, 2001 (Monday)

Sir:

Applicant respectfully requests the Examiner's authorization of the drawing corrections shown in red ink on the attached sheet(s) as follows:

Figure 2, please add element 25 "path of electron emission" as referred to on page 4, line 16 of the specification; and

Figure 2a, please delete the red-inked reference to liner 20.

No new matter has been added by these changes. These drawing changes will be implemented into formal drawings by Applicant's bonded draftsperson upon approval by the Examiner and subsequent allowance of the application.


09/414,004

If necessary, the Commissioner is hereby authorized in this, concurrent, and further replies, to charge payment or credit any overpayment to Deposit Account No. 50-1735 for any additional fees required under 37 C.F.R. § 1.16 or under 37 C.F.R. § 1.17; particularly, extension of time fees.

Respectfully submitted,

BIRCH, STEWART, KOLASCH & BIRCH, LLP

By

  
John A. Castellano  
Reg. No. 35,094

JAC:cb

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Attachments

Fig. 2(a)

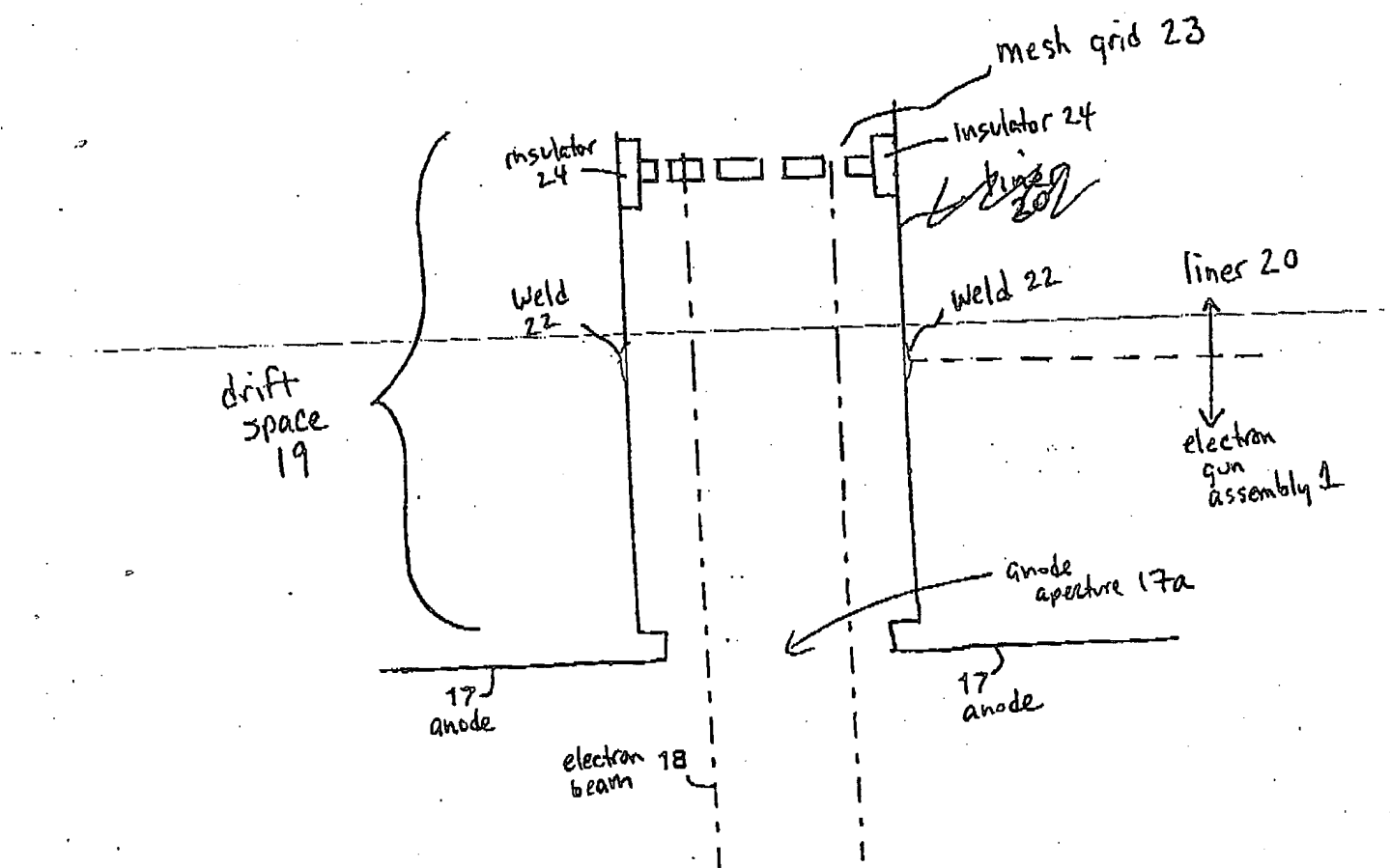


Fig. 2

